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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PRIORITY Application Serial No. 08/748,997
PRIORITY Filing Date November 14, 1996
Inventor Gurtej S. Sandhu et al.
Assignee Micron Technology, Inc.
PRIORITY Group Art Unit 1765
PRIORITY Examiner Felisa C. Hiteshew
Attorney's Docket No. MI22-1114
Title: Method Of Forming A Crystalline Phase Material

PRELIMINARY AMENDMENT

To: Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
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Sir:

Please enter the following amendments prior to examining the
above-identified application. Applicant amends and remarks as follows:
[unless otherwise indicated, deletions are bracketed, additions are
underlined].

AMENDMENTS

In the Specification

At p. 1 before the "Technical Field" section, please insert the
following: